

**Notice of References Cited**

Application/Control No.

09/887,747

Applicant(s)/Patent Under  
Reexamination  
VAN DER SCHAAAR ET AL.

Examiner

Richard Lee

Art Unit

2613

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,263,022 B1	07-2001	Chen et al.	375/240.03
	B	US-2003/0026340 A1	02-2003	Divakaran et al.	375/240.24
	C	US-6,057,884 A	05-2000	Chen et al.	375/240.16
	D	US-5,995,150 A	11-1999	Hsieh et al.	375/240.12
	E	US-6,072,831 A	06-2000	Chen, Xuemin	375/240.03
	F	US-5,886,736 A	03-1999	Chen, Xuemin	375/240.1
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
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	X	

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